



MS AF  
REPLY UNDER  
37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2815

PATENT  
0717-0446P

ENTERED  
W/ RCE  
8.2.04

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Atsushi SHIMONAKA Conf.: 8768  
Appl. No.: 09/670,820 Group: 2815  
Filed: September 28, 2000 Examiner: Landau, M.C.  
For: SEMICONDUCTOR LASER ELEMENT AND  
ELECTRONIC DEVICE USING THE SAME

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

**MS AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 29, 2004

Sir:

In reply to the Office Action dated April 2, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes claim amendments and Remarks.